

Title: SEMICONDUCTOR LASER DEVICE AND METHOD OF
MANUFACTURING THE SAME
Inventor's Name: MIYACHI et al
Application No.: New Application
Docket No.: 107156-00220

FIG.1 A

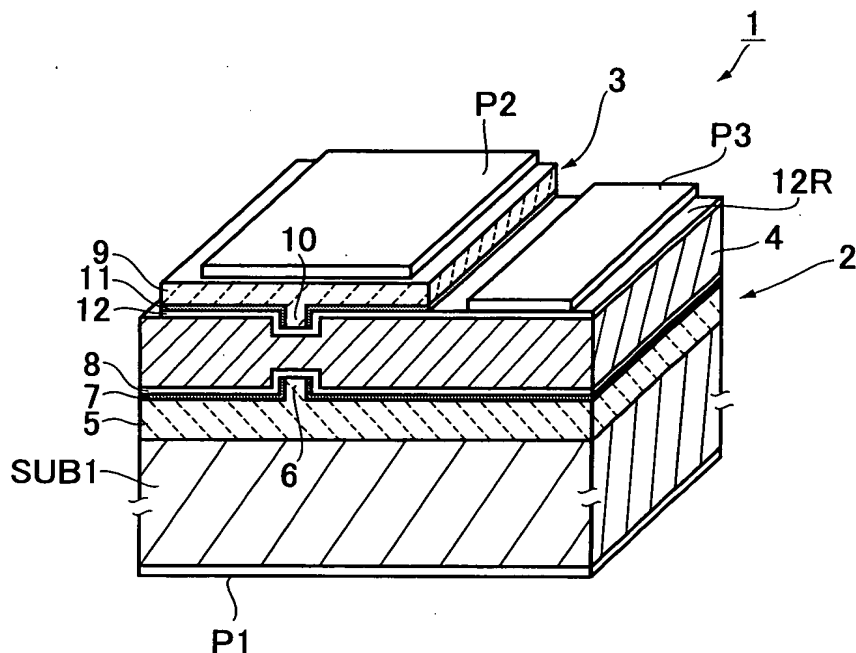
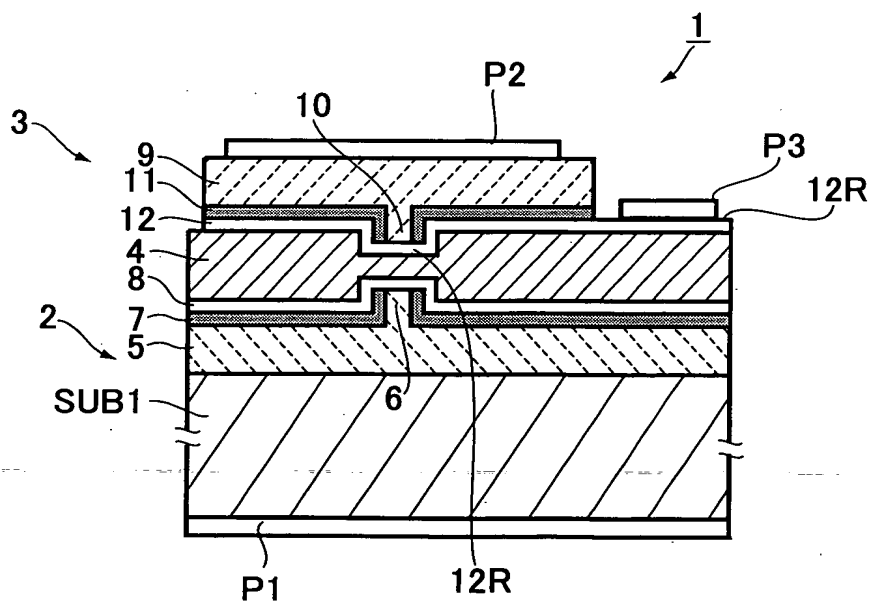


FIG.1 B



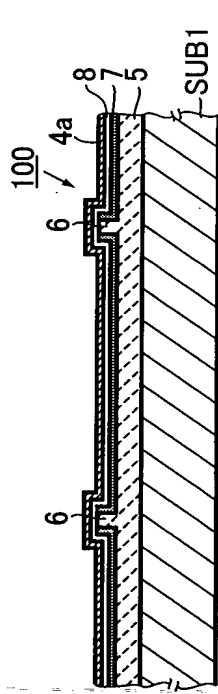


FIG. 2 A

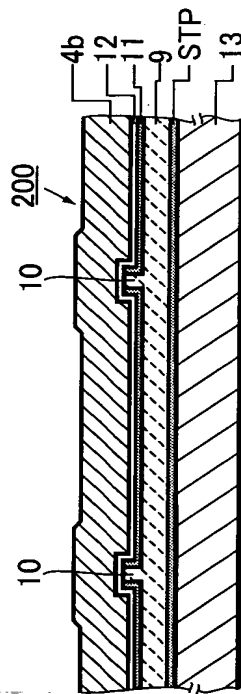


FIG. 2 B

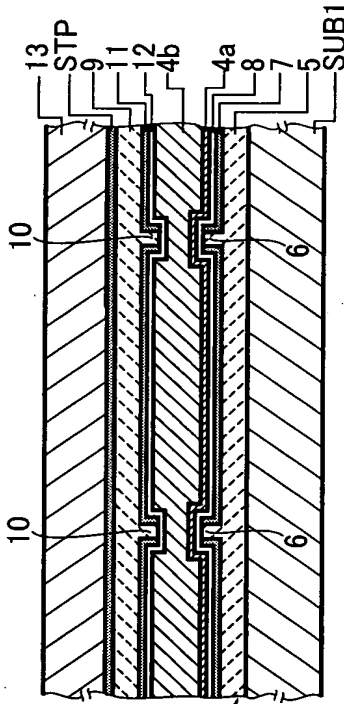


FIG. 2 C

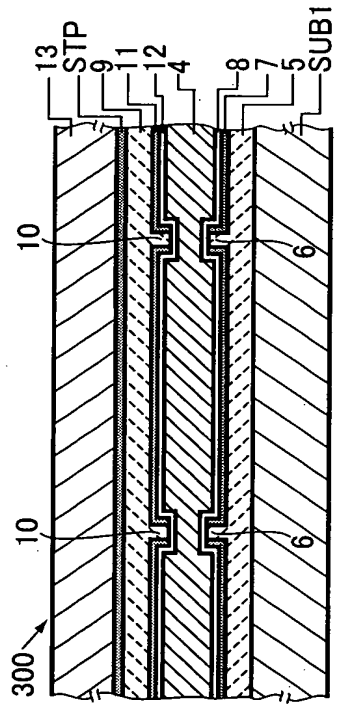


FIG. 2 D

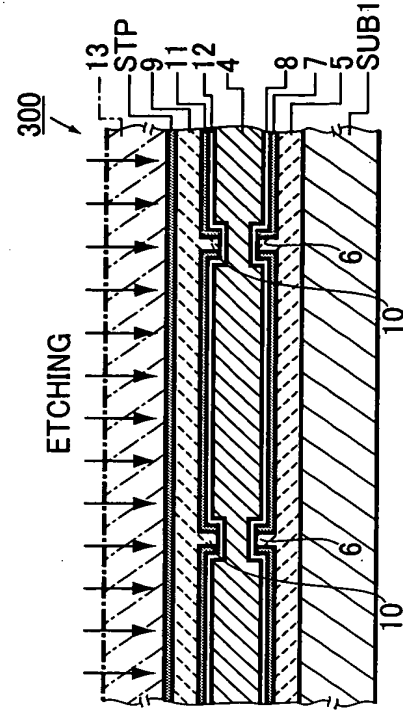


FIG. 2 E

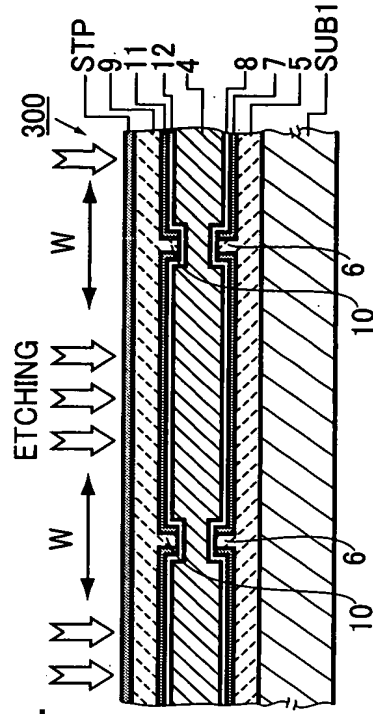


FIG. 2 F

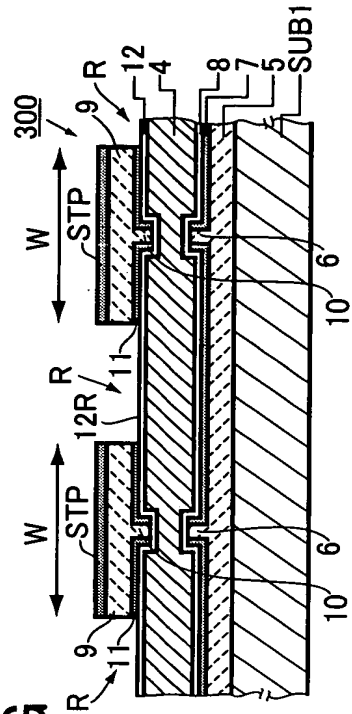


FIG. 2 G

[illegible]

FIG.4 A

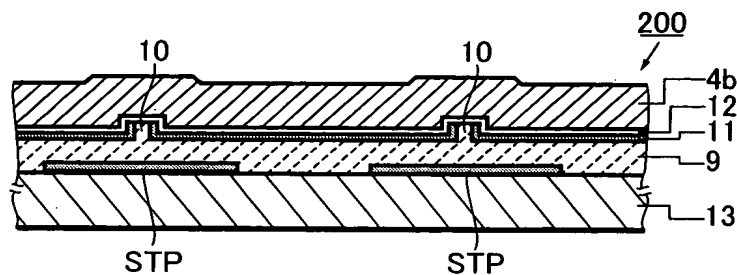


FIG.4 B

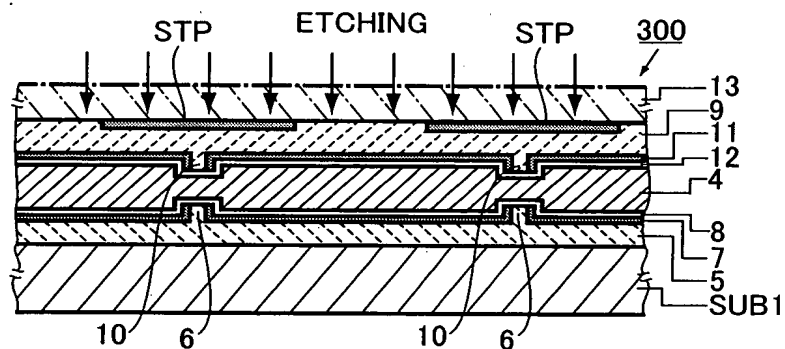


FIG.4 C

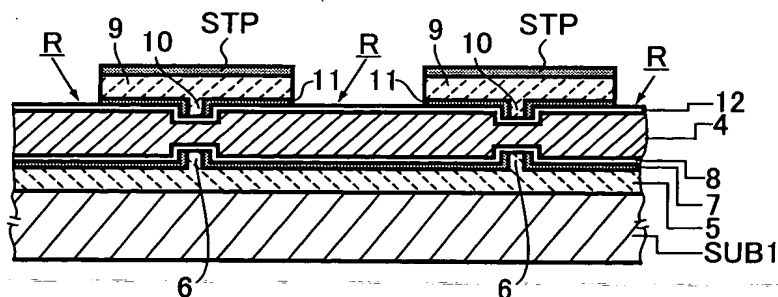


FIG.5

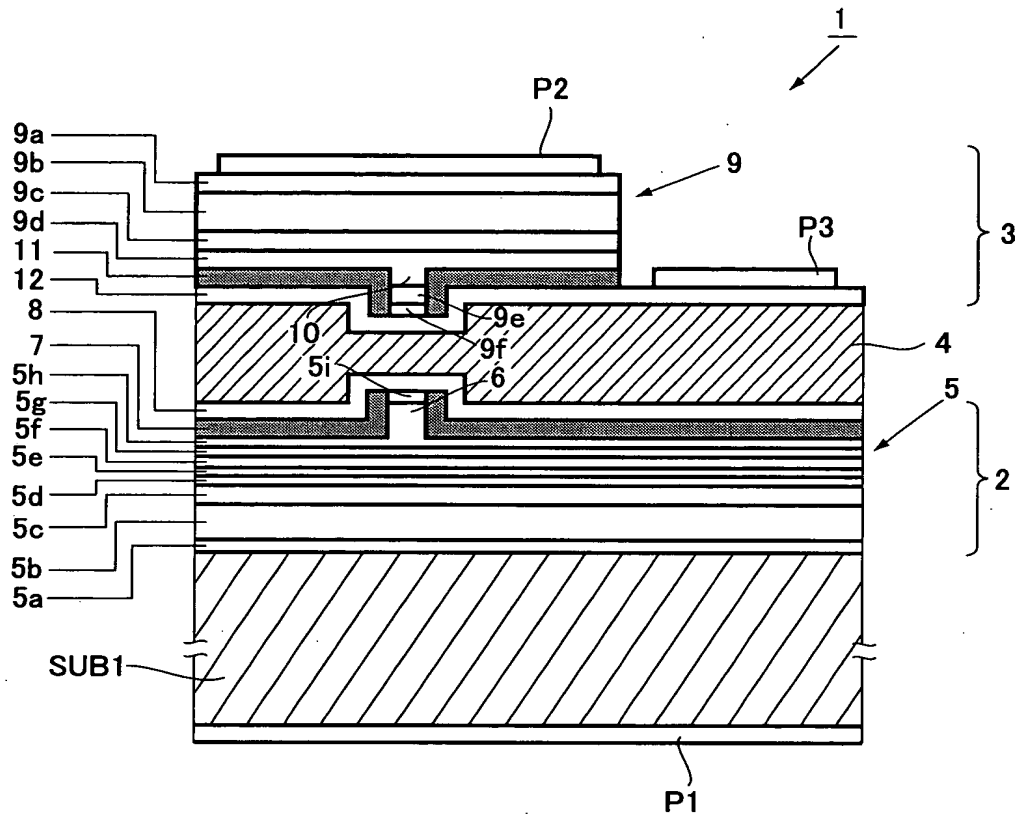


FIG.6 A

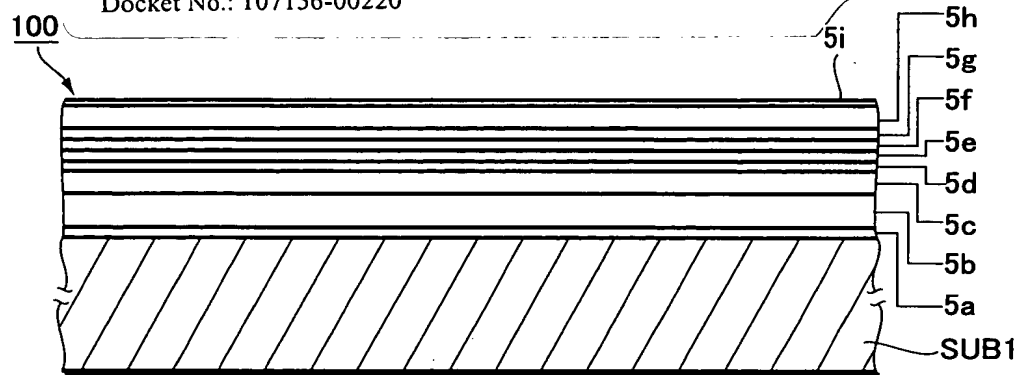


FIG.6 B

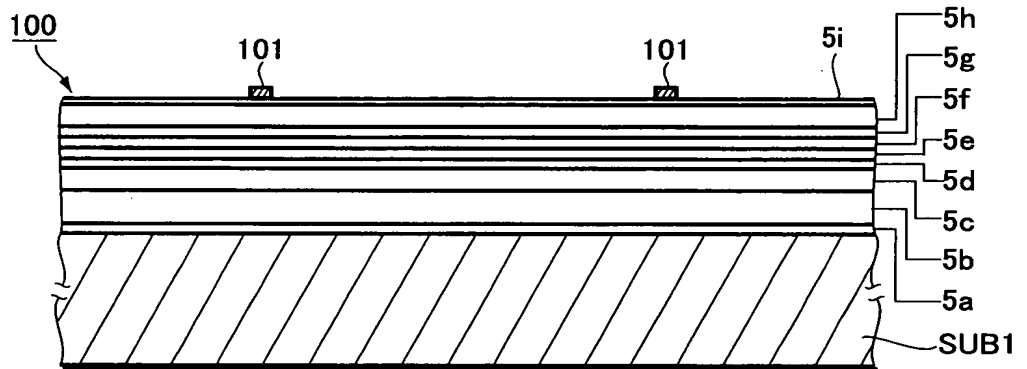


FIG.6 C

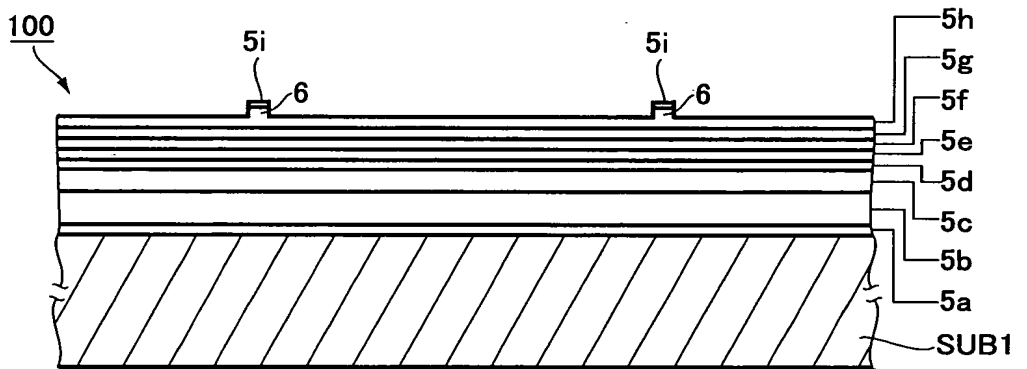


FIG.6 D

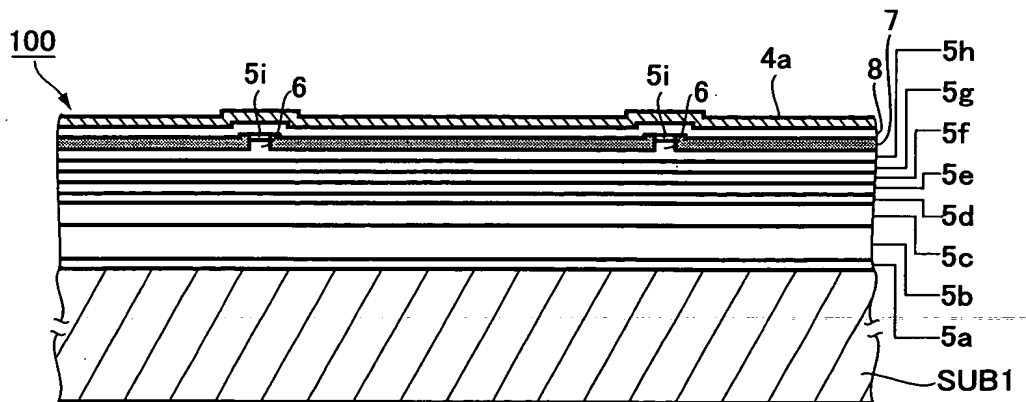


FIG.7 A

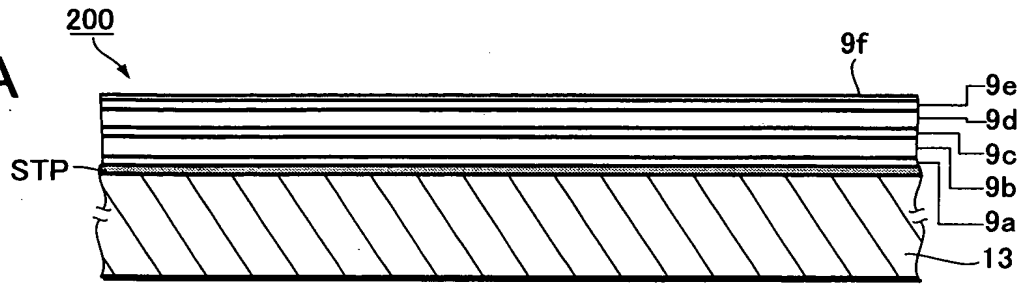


FIG.7 B

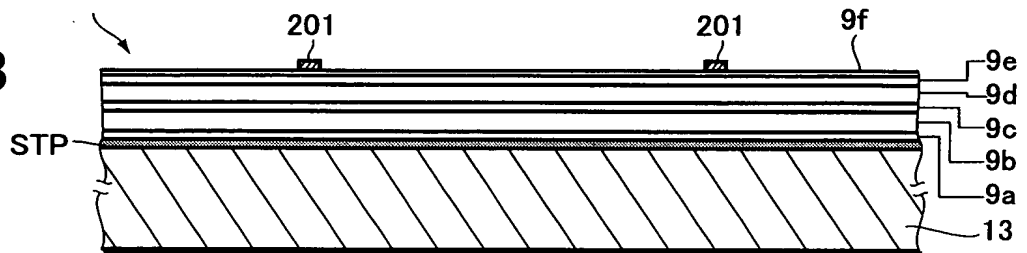


FIG.7C

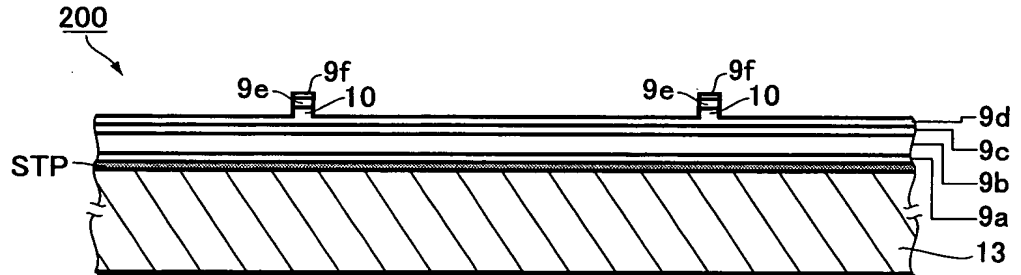


FIG.7 D

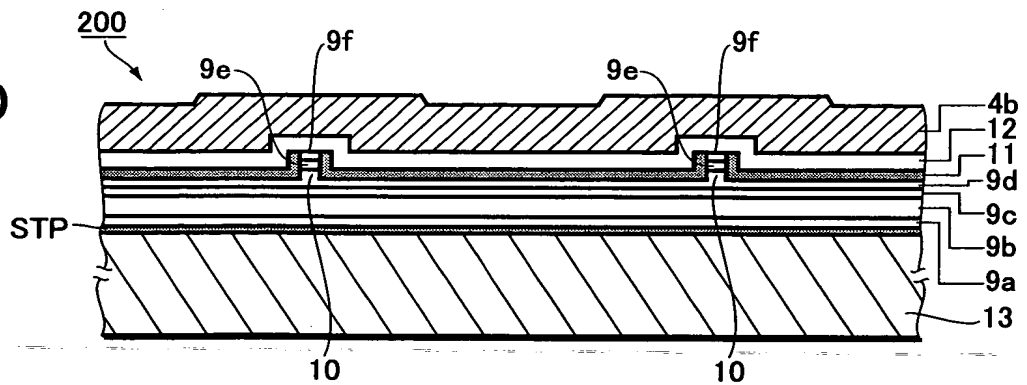


FIG.8

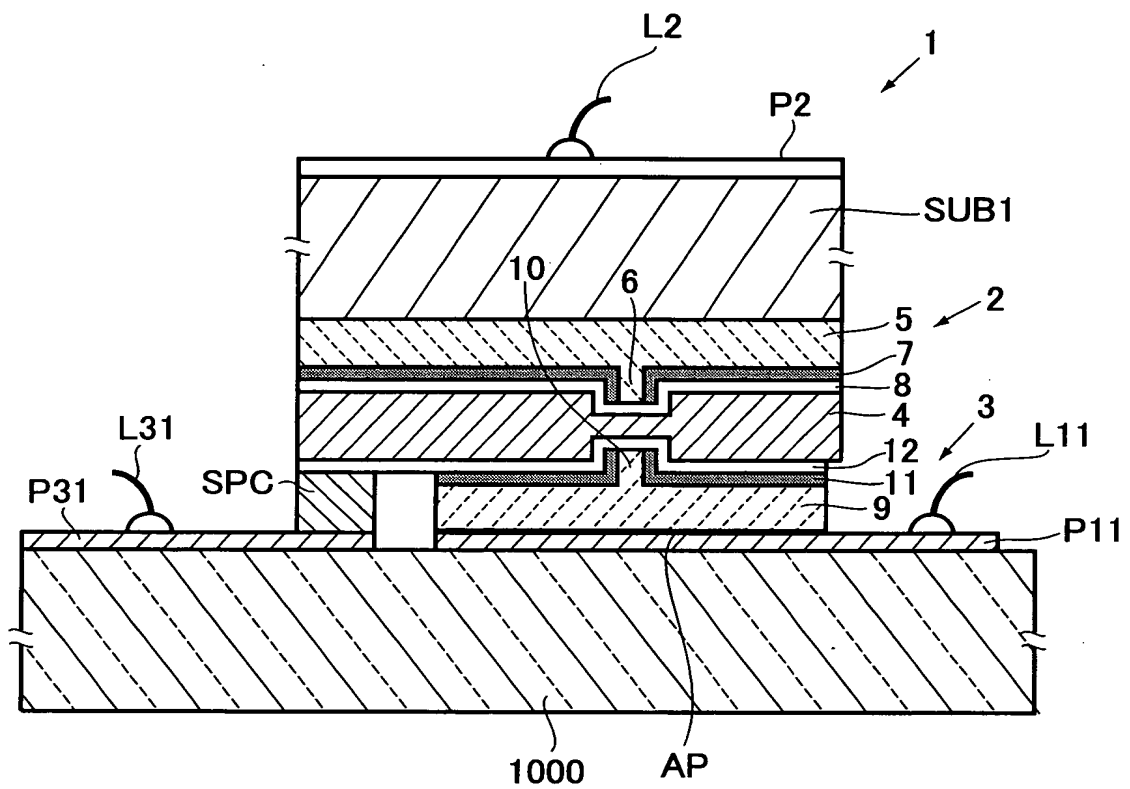


FIG.9 A

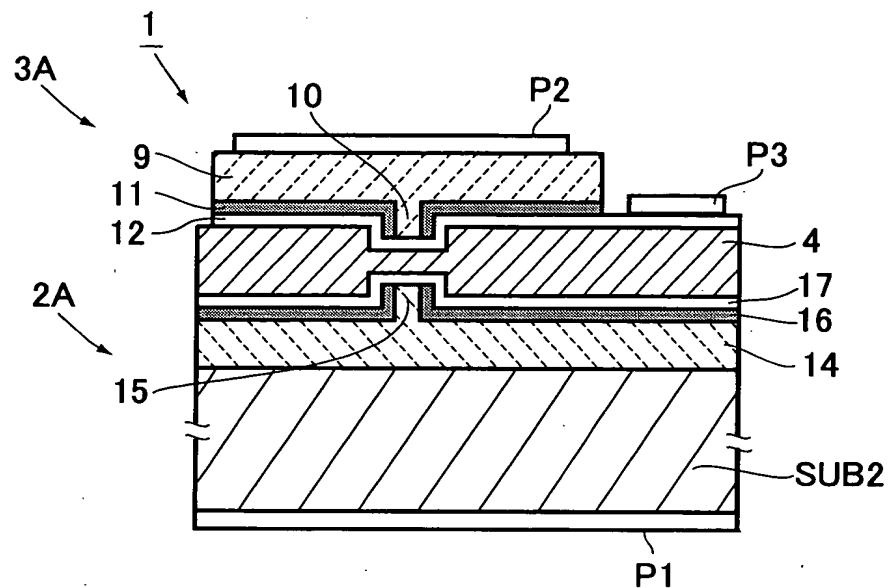


FIG.9 B

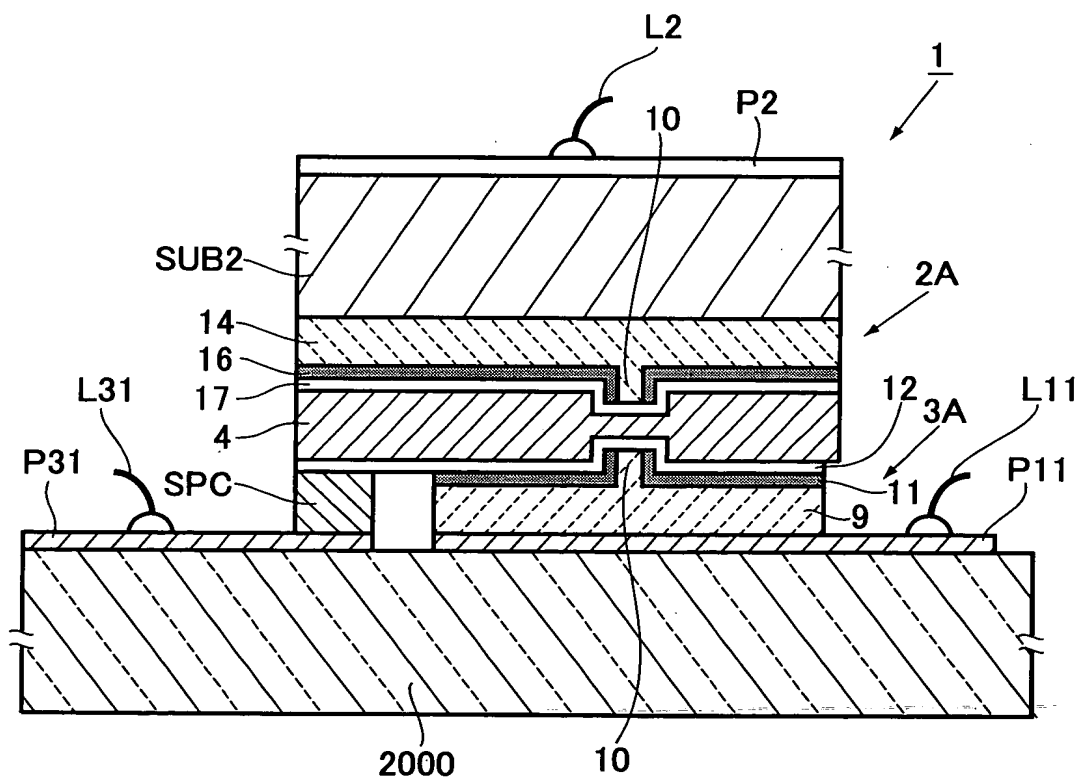


FIG.11 A

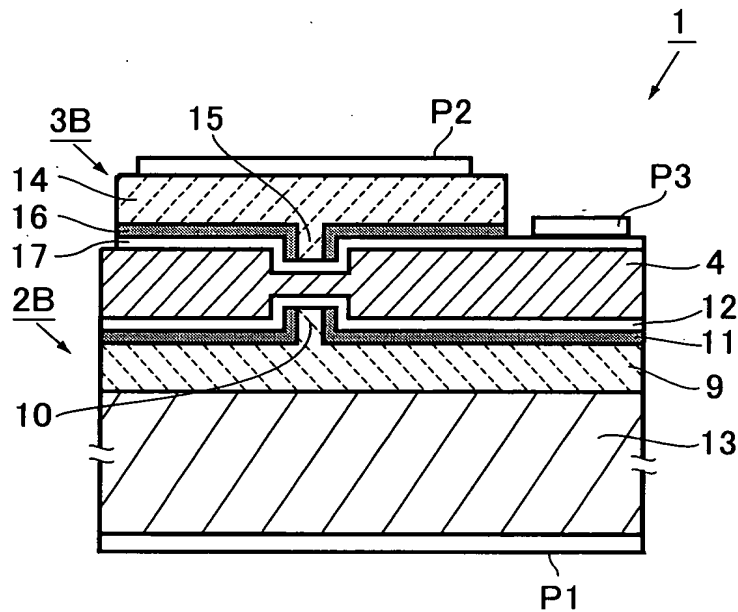
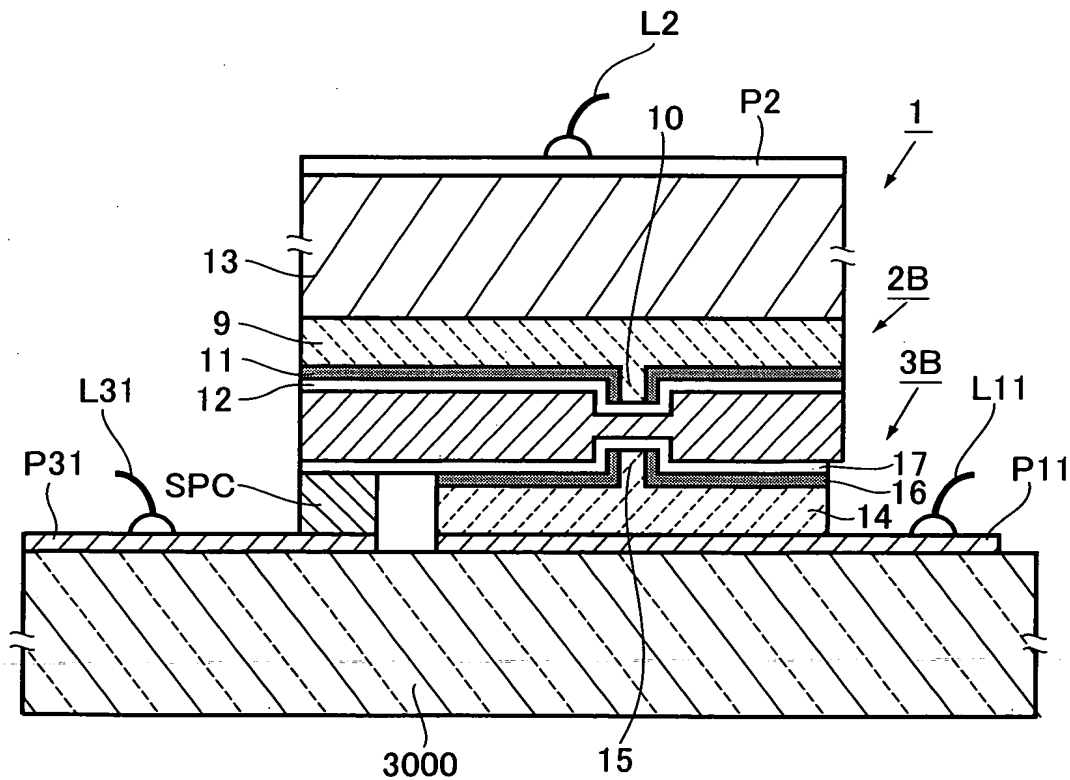


FIG.11 B



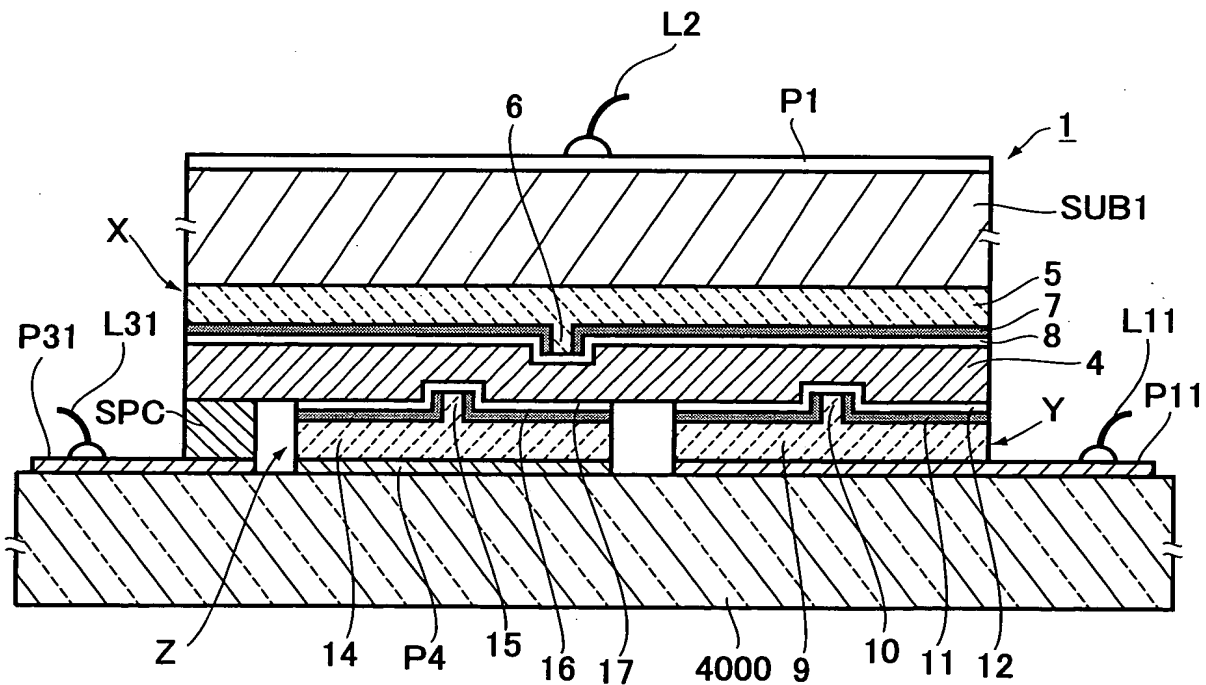


FIG.14 A

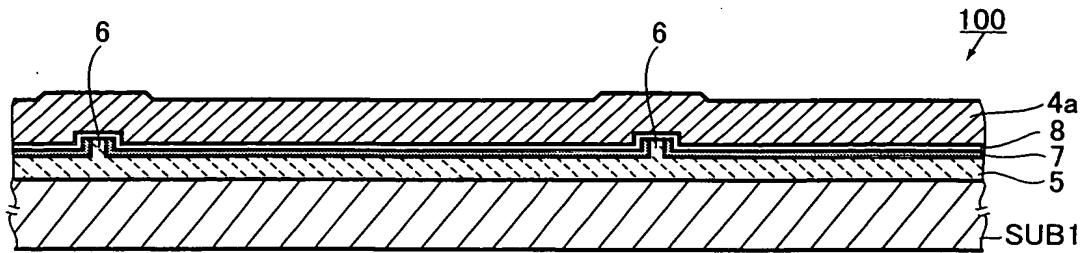


FIG.14 B

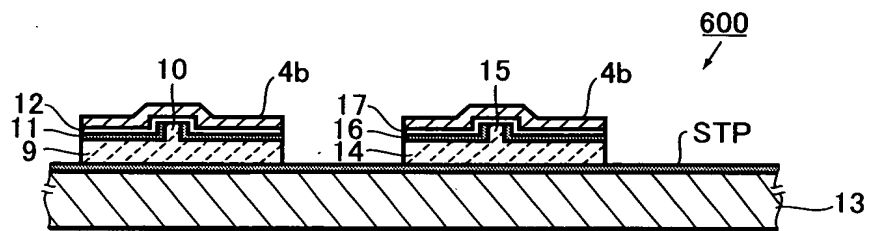


FIG.14 C

ETCHING

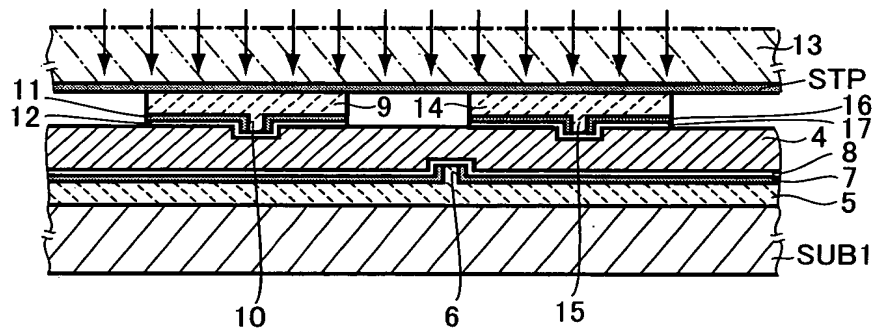


FIG.14 D

